

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Satoshi MORIYA
Application No.: 10/538,744
Filing Date: 03/20/06
Title: RESISTIVE MATERIAL, RESISTIVE ELEMENT, RESISTOR, AND
METHOD FOR MANUFACTURING THE SAME

Art Unit: 2832
Examiner: Lee, Kyung S.

Mail Stop Amendment

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO RESTRICTION REQUIREMENT

Sir:

In response to the Office Action dated March 4, 2009, please
amend the application as follows:

Amendments to the Drawings begin on page 2 of this paper.

Remarks begin on page 3 of this paper.